

Karlsruhe Institute of Technology



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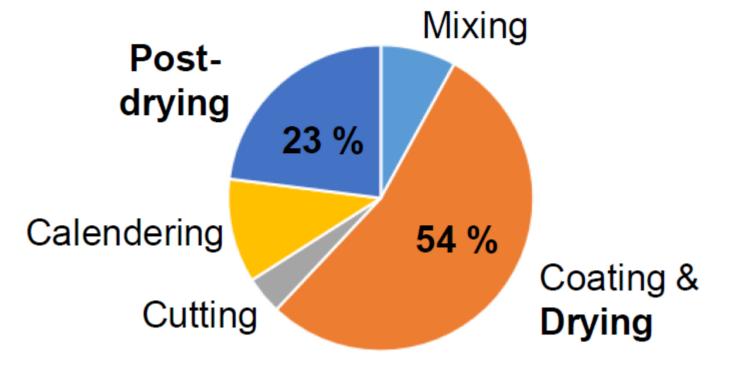


Development of a New Dryer Concept for Agile Drying of Battery Electrodes J. Mohacsi^{1,2}, A. Altvater^{1,2}, P. Scharfer^{1,2}, W. Schabel^{1,2}

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Motivation

Production cost of electrodes



Drying of electrodes

- Cost intensive
- Energy intensive
- High impact on properties &



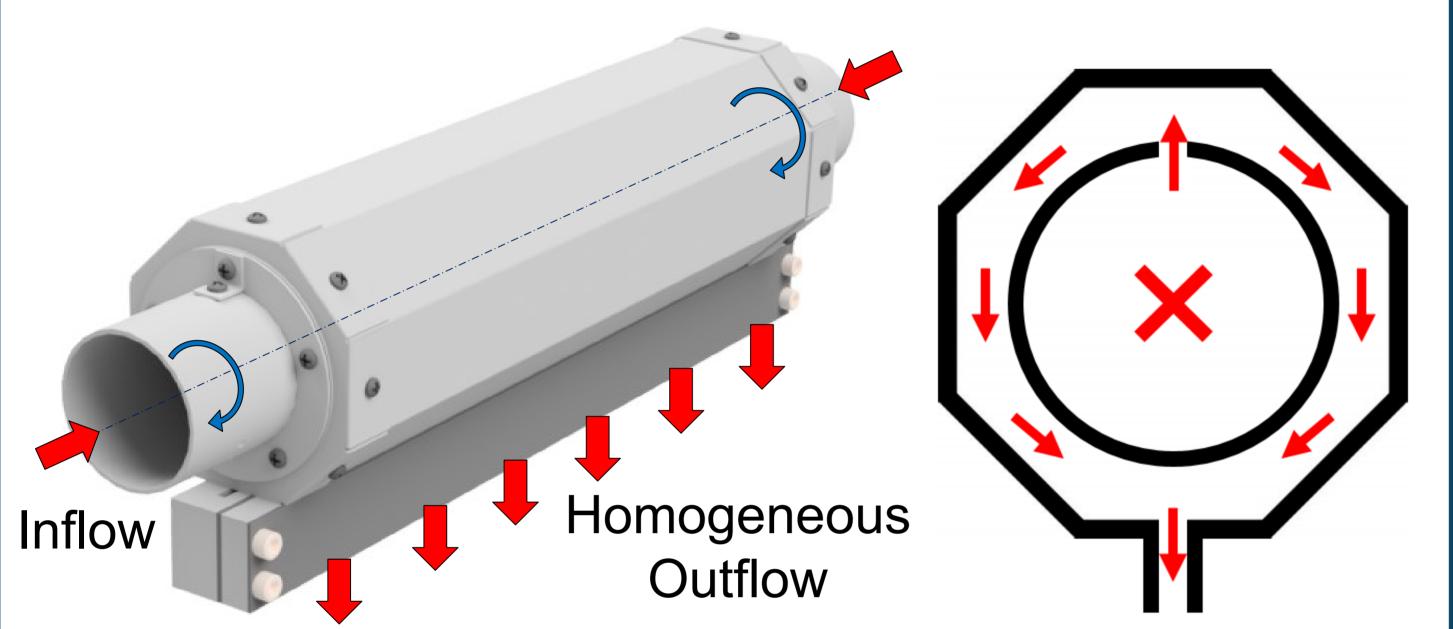
[1] Bosten Consulting Group, 2018

performance

Error prone (high risk of waste)

New dryer concept for agile drying of battery electrodes

Drying Nozzle Concepts

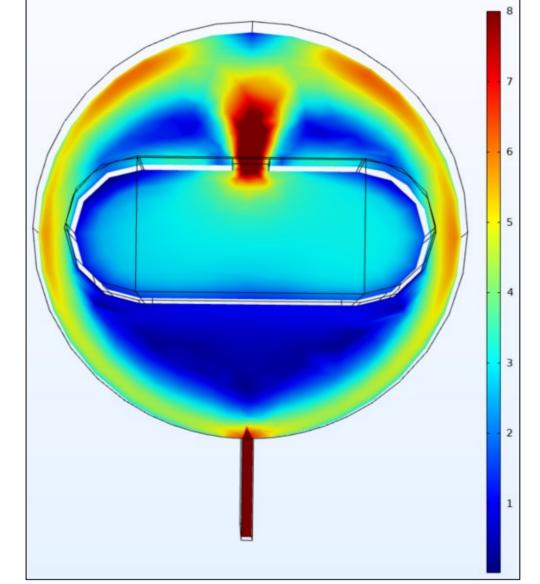


- adjustable
- Air path: high local pressure loss
 - \rightarrow Homogeneous velocity distribution

Homogeneous Heat Transfer Coefficients

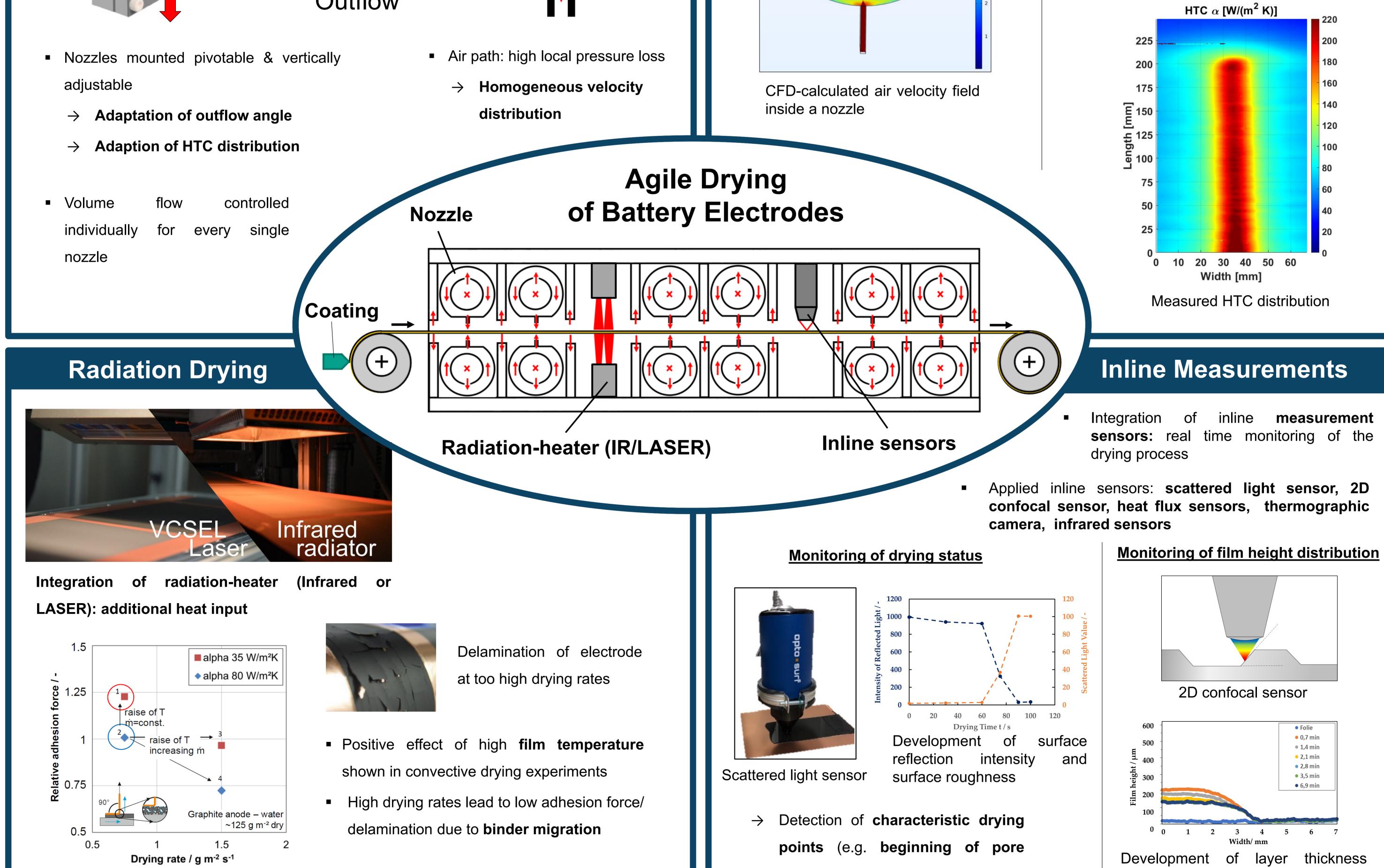
Nozzle concepts developed & optimized:

Simulations (CFD)



Experiments (TLC)

- Experiments based on thermo-chromatic liquid crystals (TLC):
 - \rightarrow Detailed analyzing of HTCdistribution for different nozzles
 - Validation of CFD-simulations \rightarrow
 - Optimizing nozzle geometries \rightarrow



- Higher energy efficiency \rightarrow
- Higher drying temperatures: Reduction of drying time (Increase of production) \rightarrow capacity, decrease of costs)
- Additional degree of freedom to react on changing production conditions

emptying)

distribution during the drying process

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- Definition of Quality Gates: early waste detection
- Track und Trace: collected data related to single sheets/cells
- Goal: less waste (less costs), higher electrode quality despite altering conditions \rightarrow

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